

Fig.2

TITLE: CHEMICAL MECHANICAL POLISHING SYSTEM AND PROCESS  
INVENTORS NAME: Paul A. Farrar  
DOCKET NO.: 1303.018US1

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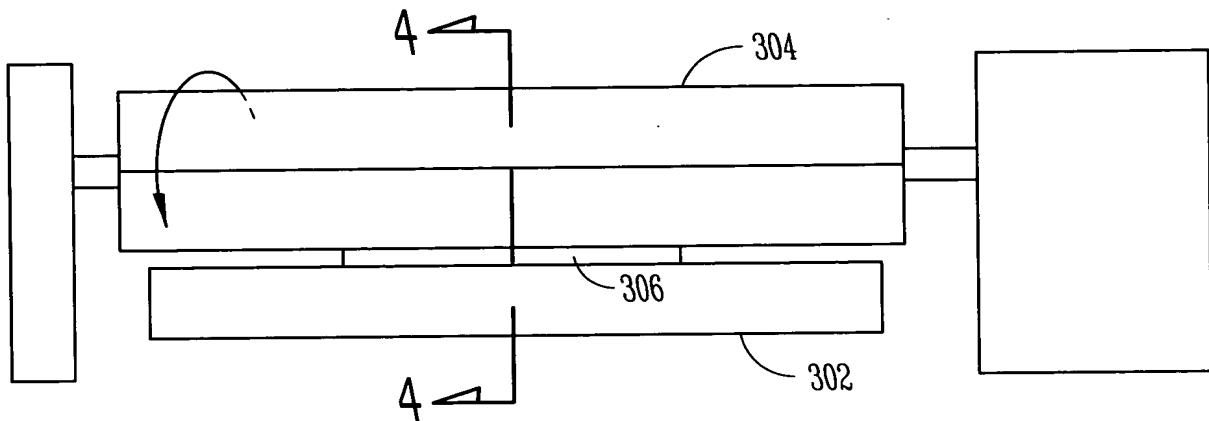


Fig.3

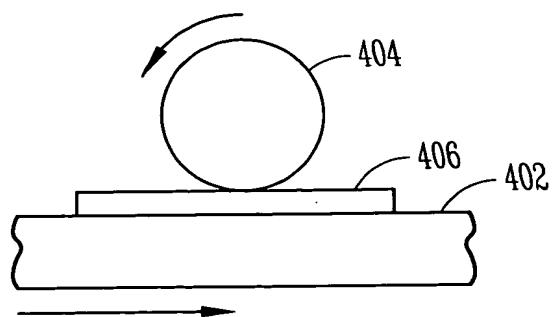


Fig.4

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500 →

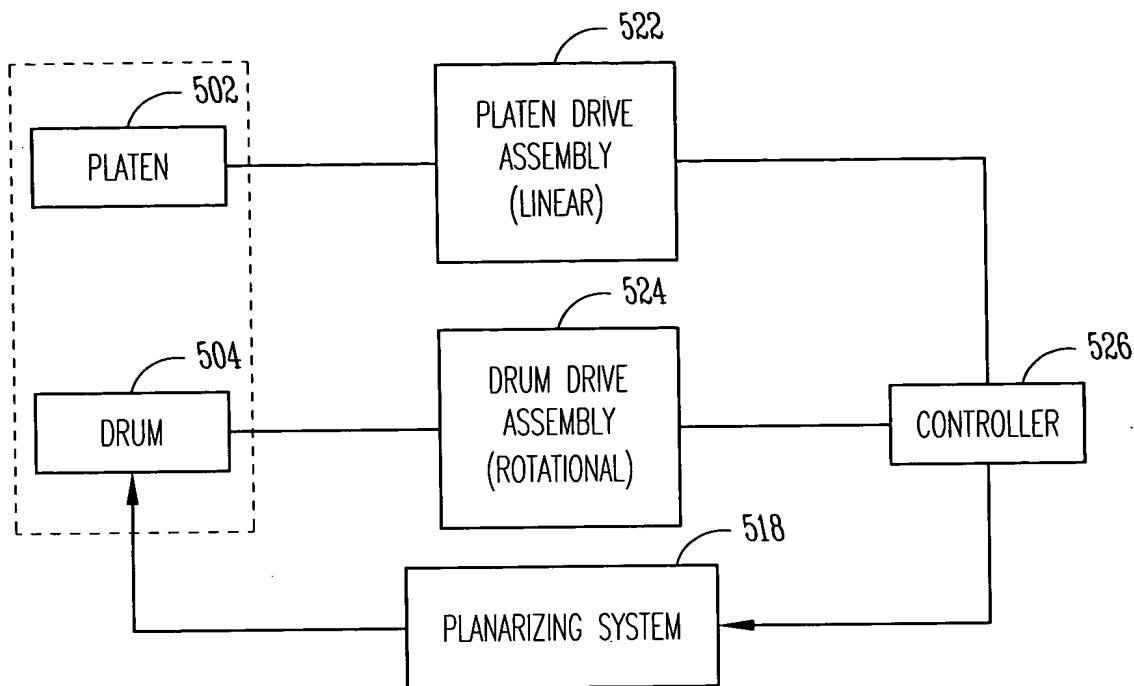


Fig.5

600 →

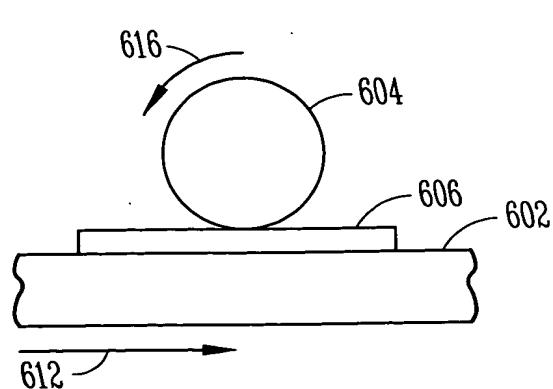


Fig.6

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700

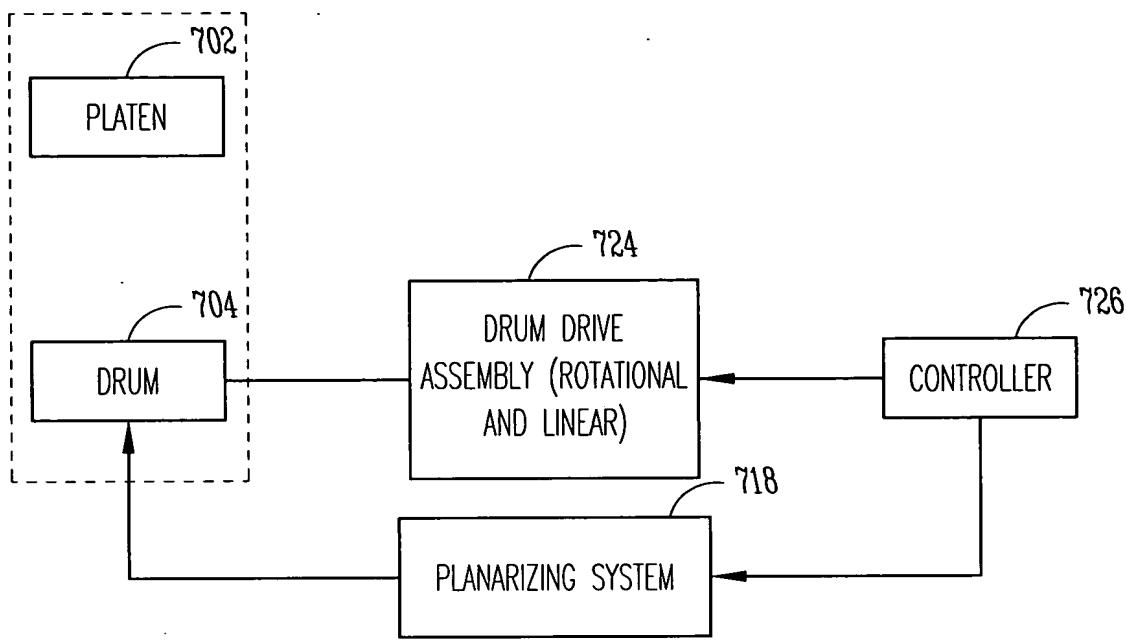


Fig.7

00000000000000000000000000000000

800

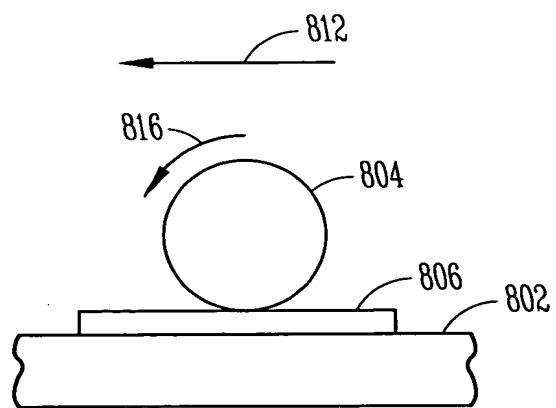


Fig.8

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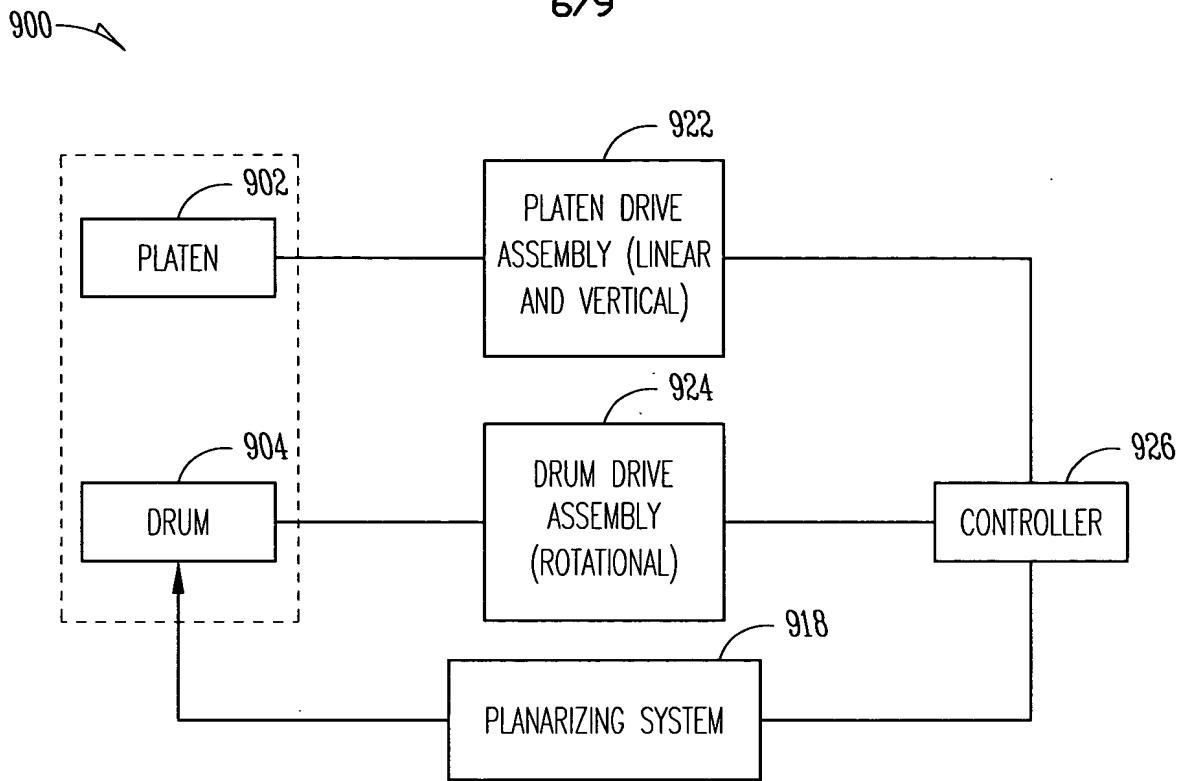


Fig.9

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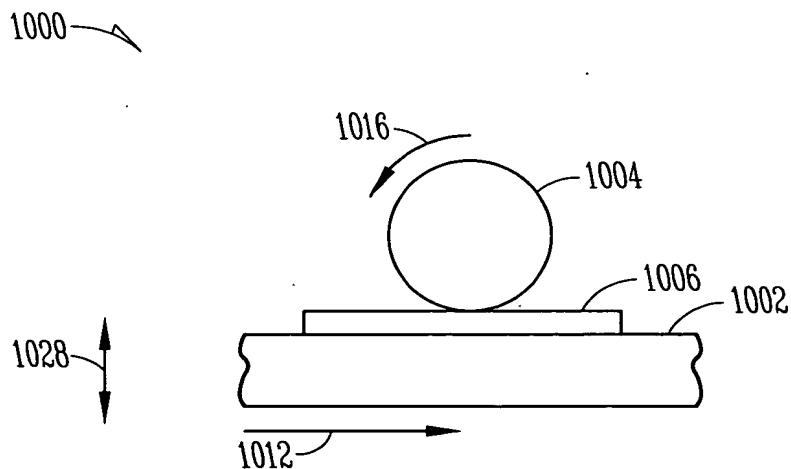


Fig.10

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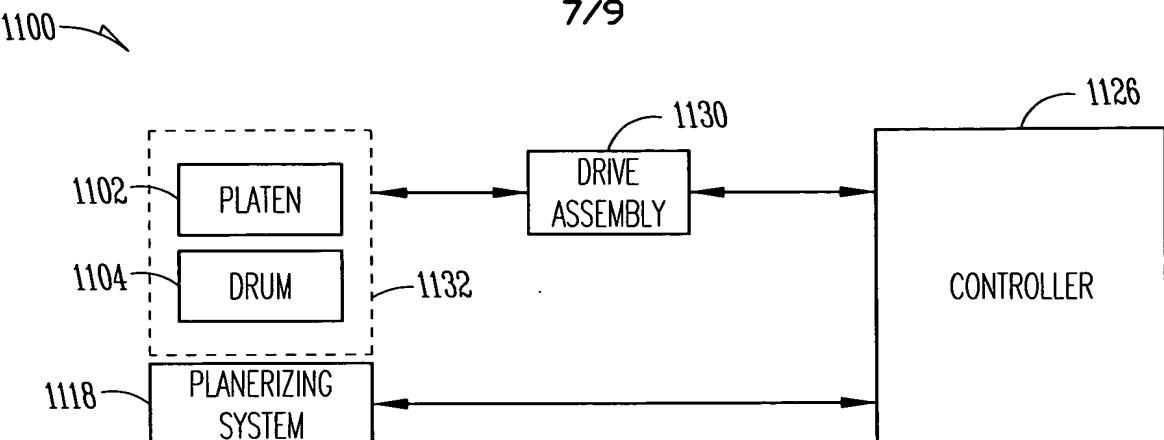


Fig.11

1200

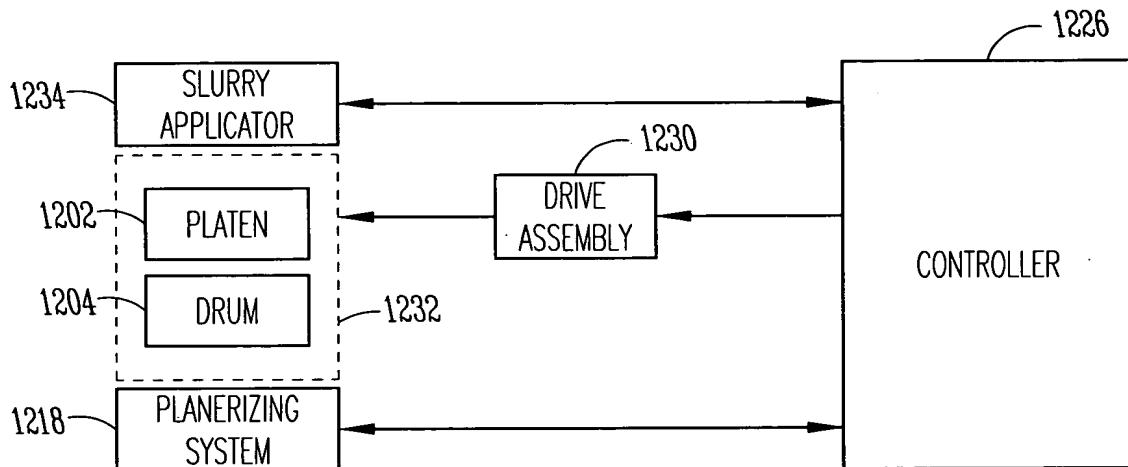


Fig.12

1326

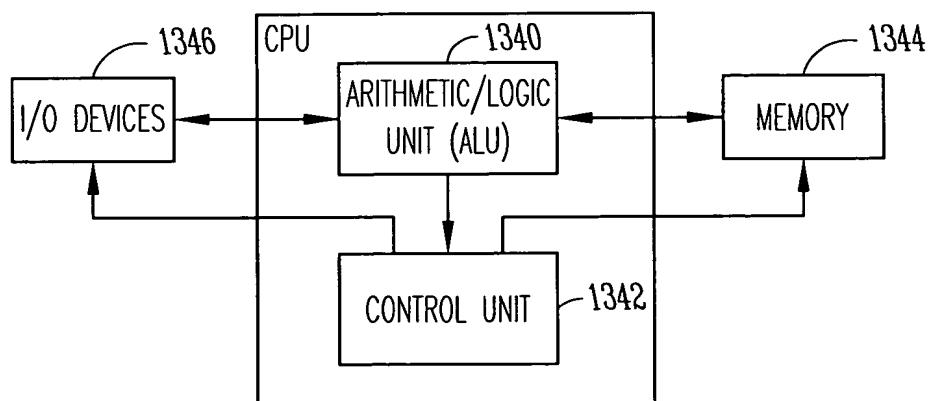


Fig.13

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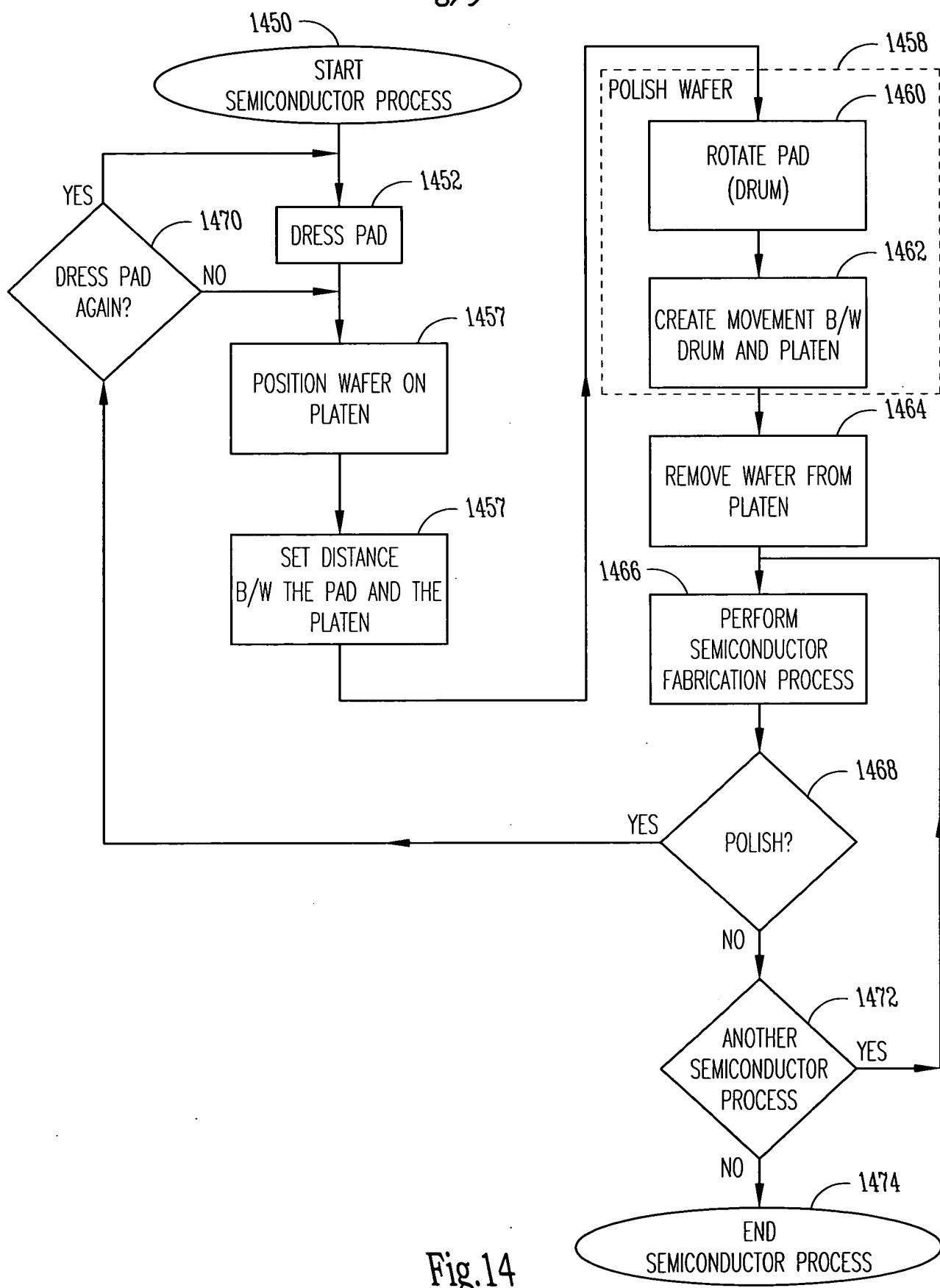


Fig. 14

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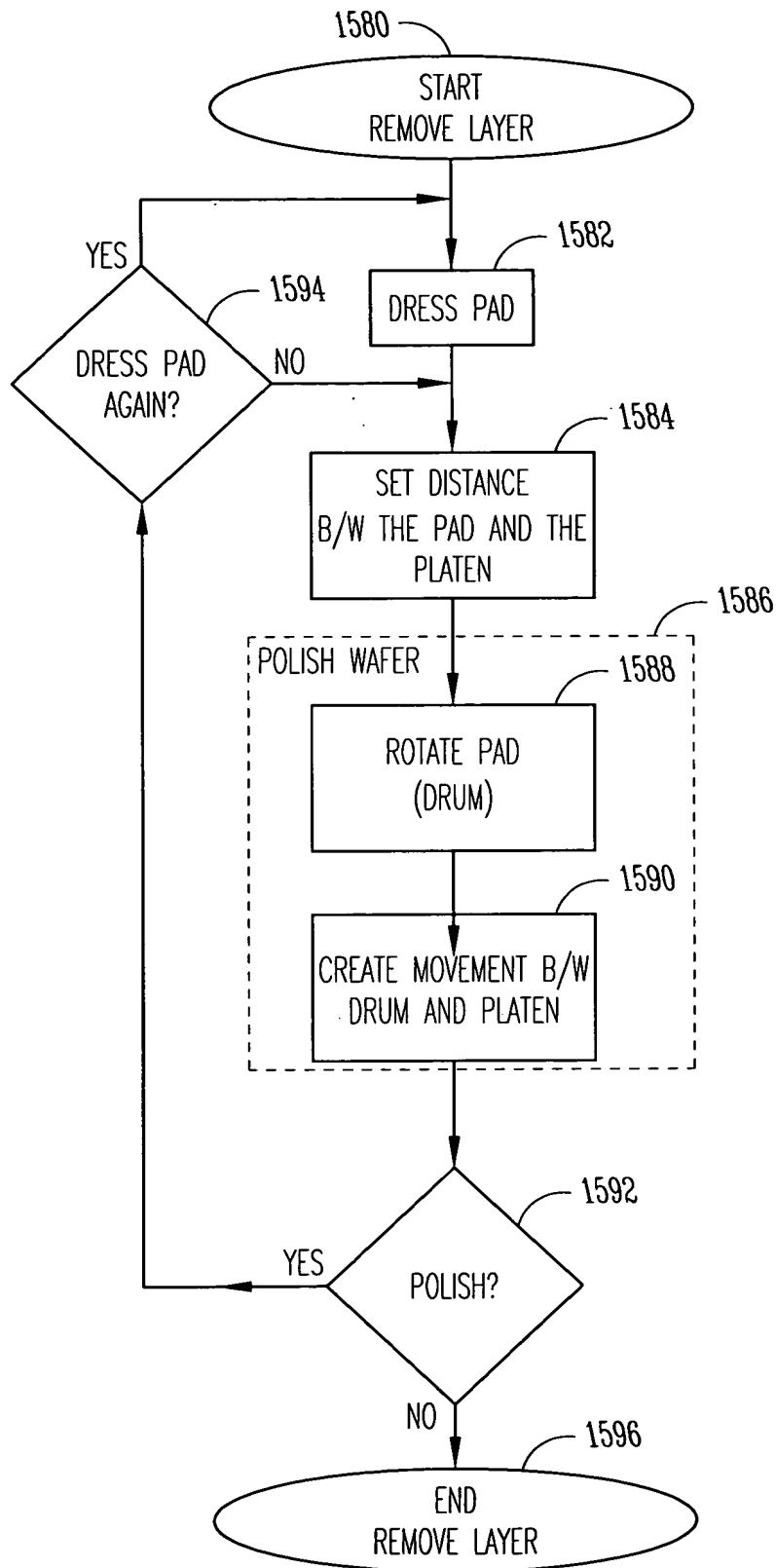


Fig.15